

Preparation of Pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ by Metal-Organic Chemical Vapor Deposition

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Ca-Ti-O films were prepared by metal-organic chemical vapor deposition (MOCVD) using $\text{Ca}(\text{dpm})_2$ and $\text{Ti}(\text{O-i-Pr})_2(\text{dpm})_2$ precursors, and the effects of substrate temperature (T_{sub}) and Ca/Ti ratio ($R_{\text{Ca}/\text{Ti}}$) on the crystal structure and morphology were studied. Ca-Ti-O films consisting of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ and perovskite CaTiO_3 phase were obtained at $T_{\text{sub}} = 1073 \text{ K}$ and $0.35 < R_{\text{Ca}/\text{Ti}} < 1$. The content of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ increased with decreasing $R_{\text{Ca}/\text{Ti}}$. Pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ almost in a single phase was obtained at $R_{\text{Ca}/\text{Ti}} = 0.46$. The morphology of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ was agglomerated fine grains about 50 nm in diameter having a columnar texture. [doi:10.2320/matertrans.47.2603]

(Received June 27, 2006; Accepted August 25, 2006; Published October 15, 2006)

Keywords: metal-organic chemical vapor deposition, calcium titanate, pyrochlore, microstructure

1. Introduction

Since a Ca-Ti-O system contains many useful materials, so many studies on the phase diagram and crystal structure of calcium titanates have been reported.¹⁾ Perovskite, CaTiO_3 , and several compounds such as $\text{Ca}_4\text{Ti}_3\text{O}_{10}$ and $\text{Ca}_3\text{Ti}_2\text{O}_7$ have been known as stable phases in the Ca-Ti-O system. Savenko and Sakharov reported a cubic phase of $\text{Ca}_2\text{Ti}_5\text{O}_{12}$ having a lattice parameter of 0.862 nm.²⁾ They prepared this compound by thermal decomposition of mixed hydroxides of Ti and Ca at 1023 K. This compound partially transformed to perovskite CaTiO_3 and rutile TiO_2 at 1273 K, and completely transformed at 1373 K. Ball and White re-indexed the XRD data by Savenko and Sakharov, and concluded that the metastable phase should be pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ having a lattice parameter of 0.995 nm.³⁾ Since then, no paper on the preparation of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ has been published.

Pyrochlore has a general composition formula of $\text{A}_2\text{B}_2\text{-X}_6\text{Y}$, where A and B are metals, and X and Y are O, OH or F. Since pyrochlore oxides have unique properties such as giant magnetoresistance (GMR) of $\text{Tl}_2\text{Mn}_2\text{O}_7$,⁴⁾ metal-insulator transition of $\text{Tl}_2\text{Ru}_2\text{O}_{7-\delta}$ ⁵⁾ and anomalous Hall effect of Mo system pyrochlore,⁶⁾ pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ would also have interesting properties. However, the thermal decomposition process can prepare only a powder form of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$, and pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ bodies can not be obtained by sintering due to the transformation to perovskite.

We have been studying metal-organic chemical vapor deposition (MOCVD) of Ca-Ti-O system, and firstly prepared pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$. In this paper, the effects of substrate temperature (T_{sub}) and Ca/Ti ratio ($R_{\text{Ca}/\text{Ti}}$) on the formation of pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ were reported.

2. Experimental Procedures

A vertical cold-wall type CVD apparatus was used to prepare Ca-Ti-O films. Source precursors of $\text{Ca}(\text{dpm})_2$ (bis-dipivaloylmethanato-calcium) and $\text{Ti}(\text{O-i-Pr})_2(\text{dpm})_2$ (bis-isopropoxy-bis-dipivaloylmethanato-titanium) powders were heated at 523 to 573 and 393 to 453 K, respectively. The

Table 1 Deposition condition of Ca-Ti-O film.

Precursor Temperature, T_{prec}	
Ca(dpm) ₂	: 323–573 K
Ti(OiPr) ₂ (dpm) ₂	: 193–453 K
Total gas flow rate, FR_{tot}	: $3.33 \times 10^{-6} \text{ m}^3 \text{ s}^{-1}$
Carrier Gas	: Ar
Ca(dpm) ₂	: $0.83 \times 10^{-6} \text{ m}^3 \text{ s}^{-1}$
Ti(OiPr) ₂ (dpm) ₂	: $0.83 \times 10^{-6} \text{ m}^3 \text{ s}^{-1}$
O ₂ gas glow rate, FR_{O_2}	: $1.2 \times 10^{-6} \text{ m}^3 \text{ s}^{-1}$
Total pressure, P_{tot}	: 0.8 kPa
Deposition temperature, T_{dep}	: 873–1073 K
Deposition time	: 0.3–0.9 ks
Substrate	: fused quartz glass

source vapors were carried into the CVD reactor with Ar gas. O₂ gas was separately introduced by using a double tube nozzle, and mixed with the precursor vapors above a substrate holder. The total gas flow rate ($FR_{\text{tot}} = FR_{\text{Ar}} + FR_{\text{O}_2} + FR_{\text{source vapor}}$) was fixed at $3.33 \times 10^{-6} \text{ m}^3 \text{ s}^{-1}$. The total pressure (P_{tot}) in the CVD reactor was kept at 0.8 kPa, and the substrate temperature (T_{sub}) was changed from 873 to 1073 K. Detailed experimental set up and the experimental procedure were reported elsewhere.⁷⁾ The deposition conditions are summarized in Table 1. Fused quartz glass plates (10 × 15 × 0.5 mm) were used as substrates. The crystal structure was identified by X-ray diffraction (XRD). The microstructure was observed by scanning electron microscopy (SEM) and transmission electron microscopy (TEM).

3. Results and Discussion

Figure 1 shows that the XRD patterns of the Ca-Ti-O films prepared at $T_{\text{sub}} = 1073 \text{ K}$ and $P_{\text{tot}} = 0.8 \text{ kPa}$. The Ca-Ti-O films consisted of perovskite CaTiO_3 , pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ and anatase TiO_2 . A small amount of $\text{Ca}_2\text{Ti}_2\text{O}_6$ phase was detected at $R_{\text{Ca}/\text{Ti}} = 0.95$ (Fig. 1(c)), and the intensity of $\text{Ca}_2\text{Ti}_2\text{O}_6$ increased with decreasing $R_{\text{Ca}/\text{Ti}}$, and the $\text{Ca}_2\text{-Ti}_2\text{O}_6$ phase became as a main phase at $R_{\text{Ca}/\text{Ti}} = 0.34$ (Fig. 1(a)). Pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ is a face-centered cubic

structure whose lattice parameter could be 0.9953 nm.³⁾ The Ca-Ti-O film showed in Fig. 1(a) was identified as a mixture of CaTiO₃, Ca₂Ti₂O₆ and a small amount of anatase TiO₂. The lattice parameter of Ca₂Ti₂O₆ was calculated as $a = 0.999$ nm that was close to that of JCPDS data of pyrochlore Ca₂Ti₂O₆.³⁾ Ca(OH)₂ peaks in Fig. 1(b) must be formed by the reaction of CaO and moisture in air after deposition. Mixed phases of CaTiO₃, anatase TiO₂ and/or CaO were obtained but no Ca₂Ti₂O₆ phase was identified at $T_{\text{sub}} = 873$ and 973 K.

Figure 2 shows the electron diffraction pattern of the Ca-Ti-O film prepared at $T_{\text{sub}} = 1073$ K, $P_{\text{tot}} = 0.8$ kPa and $R_{\text{Ca/Ti}} = 0.34$. The film was mainly Ca₂Ti₂O₆ where the incident zone axis was [001] and every electron diffraction spots were indexed as pyrochlore Ca₂Ti₂O₆.

Figure 3 shows the surface and cross-sectional morphology of the Ca-Ti-O film prepared at $T_{\text{sub}} = 1073$ K, $P_{\text{tot}} = 0.8$ kPa and $R_{\text{Ca/Ti}} = 0.34$. The film had a columnar texture as shown in Fig. 3(b). The surface had a granular micro-

structure with 300 nm in diameter, and the agglomerated grains consisted of smaller grains about 50 nm in diameter (Fig. 3(a)).

Figure 4 shows the relationship between $R_{\text{Ca/Ti}}$ and the fraction of Ca₂Ti₂O₆ phase (F) in the Ca-Ti-O films prepared at $T_{\text{sub}} = 1073$ K and $P_{\text{tot}} = 0.8$ kPa. The fraction of pyrochlore Ca₂Ti₂O₆ phase can be calculated from eq. (1).

$$F = \frac{I_{\text{Ca}_2\text{Ti}_2\text{O}_6}}{I_{\text{Ca}_2\text{Ti}_2\text{O}_6} + I_{\text{CaTiO}_3} + I_{\text{TiO}_2}} \quad (1)$$

where, I is the sum of all peaks for each phase in the Ca-Ti-O films. The Ca₂Ti₂O₆ phase formed in a Ti-rich region of $0.3 < R_{\text{Ca/Ti}} < 1$. The fraction of Ca₂Ti₂O₆ phase increased with decreasing $R_{\text{Ca/Ti}}$, and the content of Ca₂Ti₂O₆ phase reached 82% at $R_{\text{Ca/Ti}} = 0.46$. Savenko and Sakharov reported that the metastable Ca₂Ti₅O₁₂ phase formed in a Ti-rich region of $R_{\text{Ca/Ti}} = 0.2-0.4$. An excess TiO₂ may be necessary to stabilize the pyrochlore Ca₂Ti₂O₆ phase.

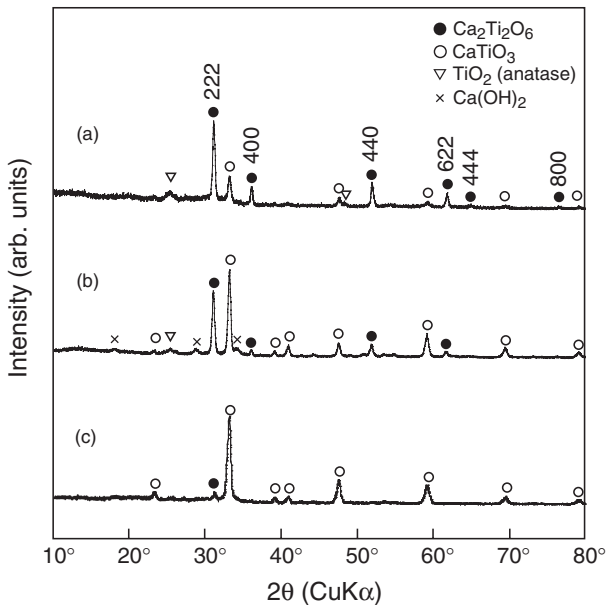


Fig. 1 XRD patterns of Ca-Ti-O films prepared at $T_{\text{sub}} = 1073$ K and $P_{\text{tot}} = 0.8$ kPa. (a) $R_{\text{Ca/Ti}} = 0.34$, (b) $R_{\text{Ca/Ti}} = 0.66$ and (c) $R_{\text{Ca/Ti}} = 0.95$.

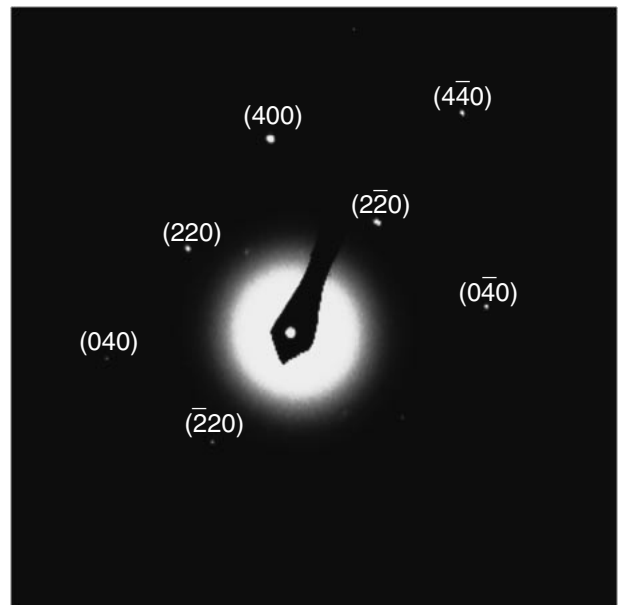


Fig. 2 Electron diffraction pattern of mainly pyrochlore Ca₂Ti₂O₆ phase prepared at $T_{\text{sub}} = 1073$ K, $P_{\text{tot}} = 0.8$ kPa and $R_{\text{Ca/Ti}} = 0.34$.

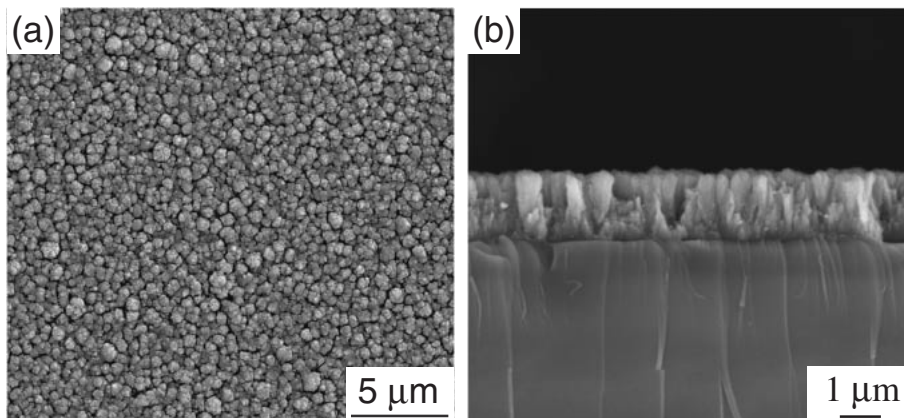


Fig. 3 Surface and cross-sectional morphologies of mainly pyrochlore Ca₂Ti₂O₆ phase prepared at $T_{\text{sub}} = 1073$ K, $P_{\text{tot}} = 0.8$ kPa and $R_{\text{Ca/Ti}} = 0.34$.

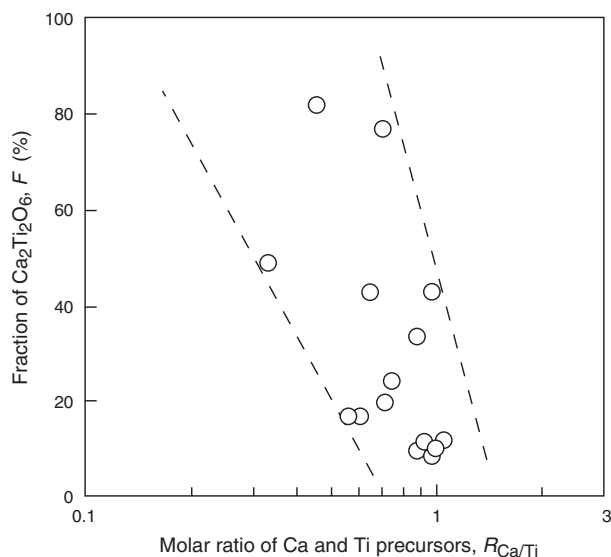


Fig. 4 Effect of $R_{\text{Ca/Ti}}$ on the peak intensity ratio of $\text{Ca}_2\text{Ti}_2\text{O}_6$ in the films prepared at $T_{\text{sub}} = 1073$ K and $P_{\text{tot}} = 0.8$ kPa.

4. Conclusions

Pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ almost in a single phase was firstly prepared by MOCVD using $\text{Ca}(\text{dpm})_2$ and $\text{Ti}(\text{O-i-Pr})_2(\text{dpm})_2$

precursors at $T_{\text{sub}} = 1073$ K, $P_{\text{tot}} = 0.8$ kPa and $0.3 < R_{\text{Ca/Ti}} < 1$. The content of $\text{Ca}_2\text{Ti}_2\text{O}_6$ phase increased with decreasing $R_{\text{Ca/Ti}}$, and reached 82% at $R_{\text{Ca/Ti}} = 0.46$. The pyrochlore $\text{Ca}_2\text{Ti}_2\text{O}_6$ showed a columnar texture consisting of agglomerated grains of 50 nm in diameter.

Acknowledgements

This research was partially supported by the Japan society for the Promotion of Science (JSPS), Grant-in-Aids for Scientific Research (B), 18360310, and the JSPS-KOSEF Asian Core University program.

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